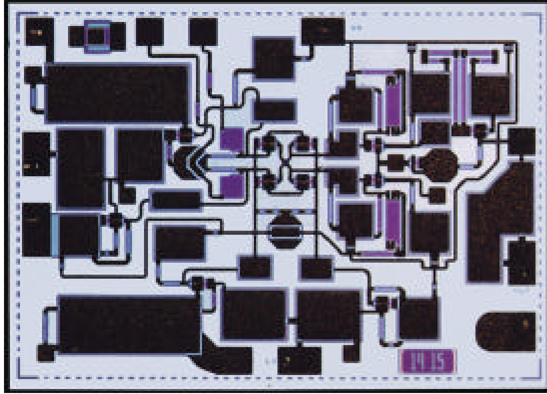
TriQuint SEMICONDUCTOR

Advance Product Information

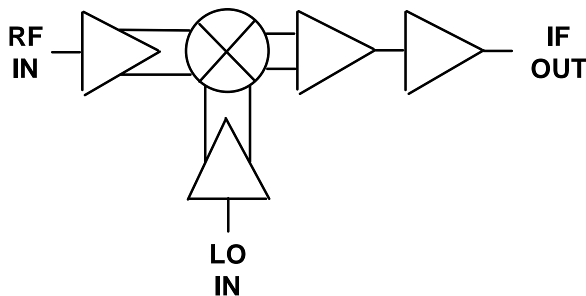
0.3 - 10 GHz Downconverter TGC1411-EPU



The TriQuint TGC1411-EPU is a double balanced MMIC mixer design using TriQuint's proven 0.25 um Power pHEMT process to support a variety of communication system applications including satellite.

The double balanced design consists of an integrated Gilbert cell mixer core, RF/LO baluns, differential combiner, and output driver amplifier. The TGC1411 may be operated from a single +3 V to +5 V power supply with typical current draw of 26 mA. The nominal LO power requirement is -5 dBm. The TGC1411 may also be operated as an up-converter.

The TGC1411 requires a minimum of off-chip components employing only a 100 pF off-chip bypass capacitor for the power supply line. No additional off-chip RF matching components are required. Each device is 100% DC and RF tested on-wafer to ensure performance compliance. The device is available in chip form.



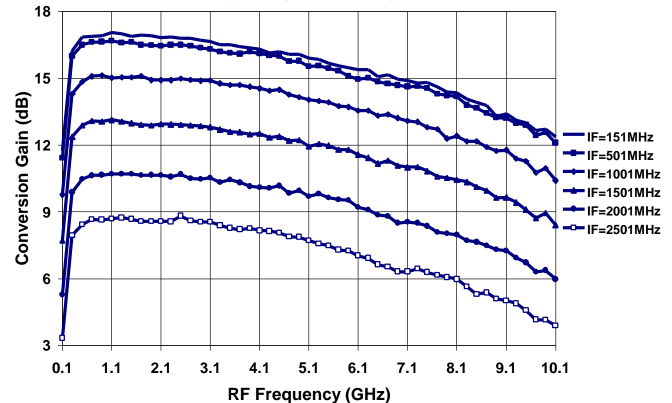
Key Features and Performance

- 0.25um pHEMT Technology
- 0.3-10 GHz RF/LO Frequency Range
- 0.15-2.5 GHz IF Frequency Range
- Nominal Conversion Gain of 12 dB
- Bias 3-5V @ 26 mA
- Chip Dimensions 1.8 mm x 2.6mm

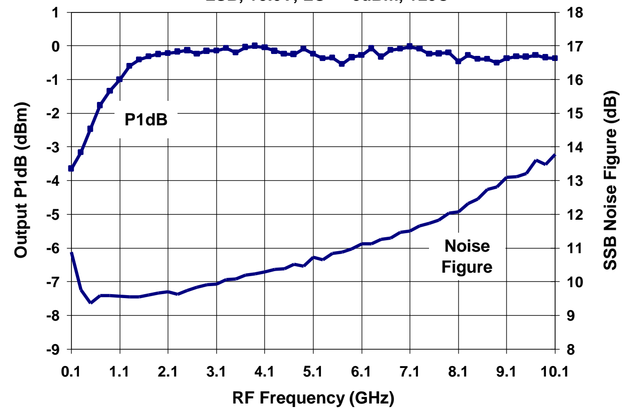
Primary Applications

- Satellite Systems
- Point-to-Point Radio

TGC 1411 **Typical Down-Conversion Gain**
LSB, +5.0V, LO = -5dBm, +25C



TGC 1411 **Typical P1dB and SSB Noise Figure**
LSB, +5.0V, LO = -5dBm, +25C



Note: Devices designated as EPU are typically early in their characterization process prior to finalizing all electrical and process specifications. Specifications are subject to change without notice.

Electrical Characteristics

RECOMMENDED MAXIMUM RATINGS

Symbol	Parameter	Value	Notes
V^+	Positive Supply Voltage	8 V	
I^+	Positive Supply Current	80 mA	3/
P_D	Power Dissipation	0.64 W	
P_{IN}	Input Continuous Wave Power	14 dBm	
T_{CH}	Operating Channel Temperature	150 °C	1/, 2/
T_M	Mounting Temperature (30 seconds)	320 °C	
T_{STG}	Storage Temperature	-65 °C to 150 °C	

1/ These ratings apply to each individual FET

2/ Junction operating temperature will directly affect the device mean time to failure (MTTF). For maximum life it is recommended that junction temperatures be maintained at the lowest possible levels.

3/ Total current for the entire MMIC

DC PROBE TESTS
(T_A = 25 °C ± 5°C)

Symbol	Parameter	Minimum	Maximum	Value
$V_{P\ Test\ FET}$	Pinch-off Voltage	-1.5	-0.5	V
$BV_{Test\ FET}$	Breakdown Voltage gate-source	-30	-8	V
$BV_{Test\ FET}$	Breakdown Voltage gate-drain	-30	-8	V

ON-WAFER RF PROBE CHARACTERISTICS
(T_A = 25 °C ± 5°C)

Symbol	Parameter	Test Condition Vd=5V, LO=-5dBm	Limit Min	Limit Nom	Limit Max	Units
G	Conversion Gain	F_{RF} = 1.0 GHz F_{LO} = 1.6 GHz	13	16	20	dB dB
ILO	LO Isolation	F_{LO} = 1.6 GHz	-	-30	-20	dB
P1dB	Output P1dB	F_{RF} = 1.0 GHz F_{LO} = 1.6 GHz	-5	-1	-	dBm
IDC	DC Current		-	26	35	mA

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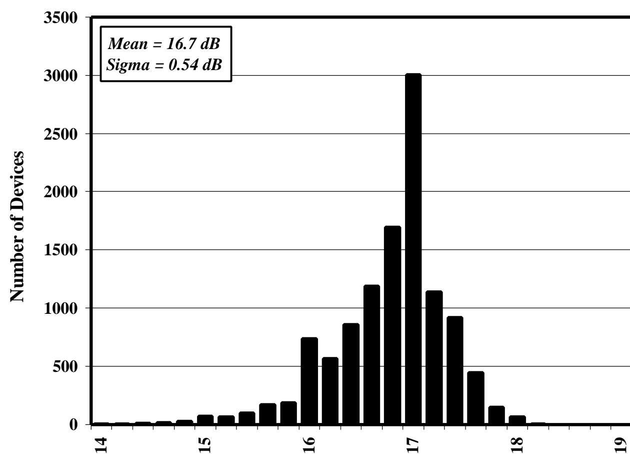
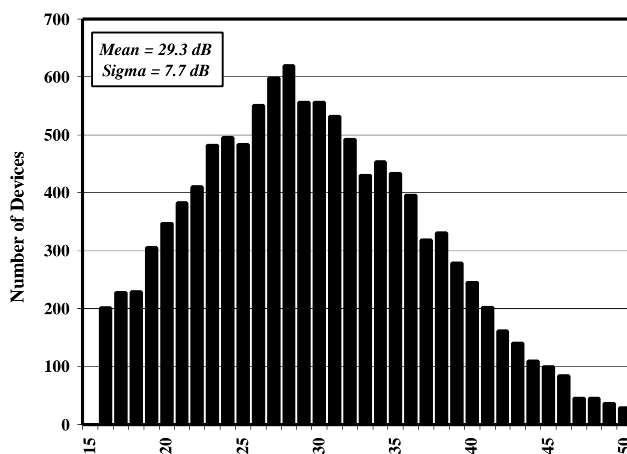
RF-Probe Performance Summary





Typical Performance

Parameter	*Units*	*+5V Supply*	*+3V Supply*
RF Frequency	GHz	0.3 - 10.0	0.3 - 10.0
IF Frequency	GHz	0.15 - 2.5	0.15 - 2.5
LO Frequency	GHz	0.45 - 12.5	0.45 - 12.5
LO Power	dBm	-5	-5
Conversion Gain*	dB	15	13
Output P_{1dB}*	dBm	-1	-8
SSB Noise Figure*	dB	11	11
LO Isolation	dB	-30	-30
Input Port Return Loss	dB	-12	-12
Output Port Return Loss	dB	-12	-12
LO Port Return Loss	dB	-12	-12
Supply Current	mA	26	22

**** IF = 501 MHz***

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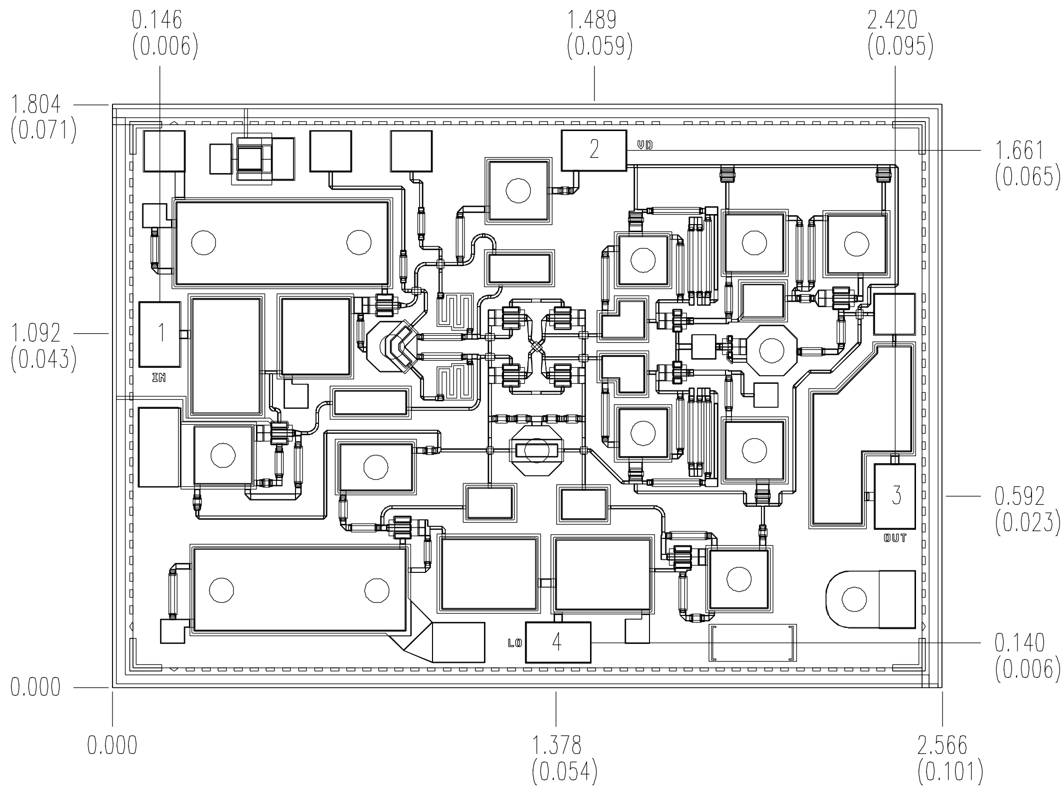
Mechanical Characteristics



Units: millimeters (inches)
Thickness: 0.1524 (0.006) (reference only)
Chip edge to bond pad dimensions are shown to center of bond pad.
Chip size tolerance: +/− 0.0508 (0.002)

Bond Pad #1 (RF Input)	0.125 x 0.200	(0.0049 x 0.0079)
Bond Pad #2 (VD)	0.125 x 0.200	(0.0049 x 0.0079)
Bond Pad #3 (RF Output)	0.125 x 0.200	(0.0049 x 0.0079)
Bond Pad #4 (LO Input)	0.125 x 0.200	(0.0049 x 0.0079)

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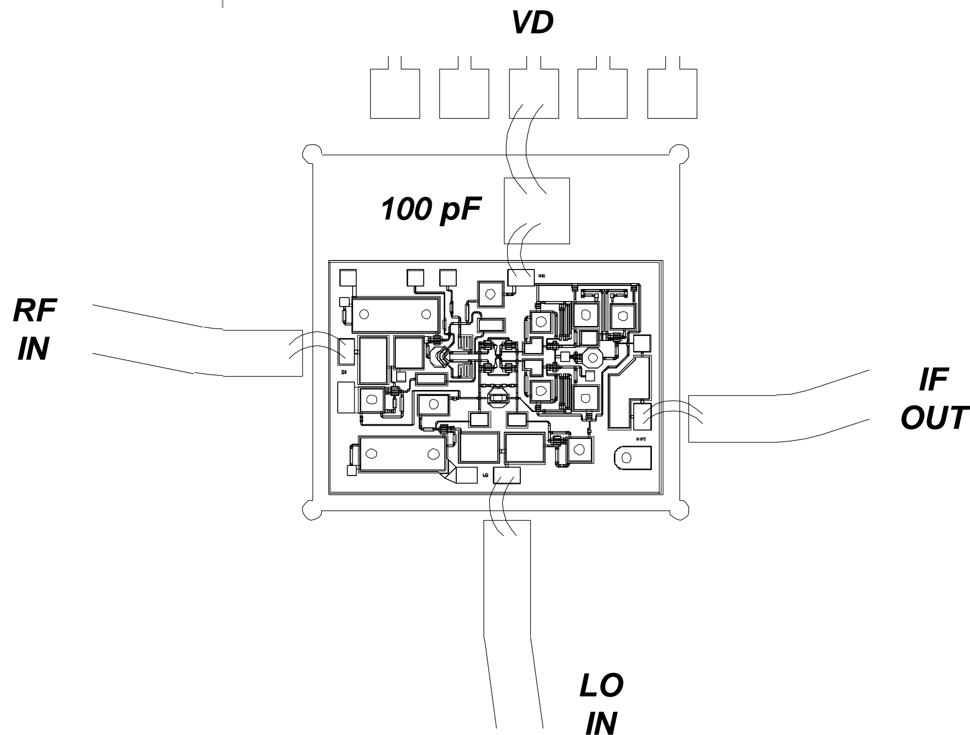

Chip Assembly and Bonding Diagram

Reflow process assembly notes:

- AuSn (80/20) solder with limited exposure to temperatures at or above 300♣C
- alloy station or conveyor furnace with reducing atmosphere
- no fluxes should be utilized
- coefficient of thermal expansion matching is critical for long-term reliability
- storage in dry nitrogen atmosphere

Component placement and adhesive attachment assembly notes:

- vacuum pencils and/or vacuum collets preferred method of pick up
- avoidance of air bridges during placement
- force impact critical during auto placement
- organic attachment can be used in low-power applications
- curing should be done in a convection oven; proper exhaust is a safety concern
- microwave or radiant curing should not be used because of differential heating
- coefficient of thermal expansion matching is critical

Interconnect process assembly notes:

- thermosonic ball bonding is the preferred interconnect technique
- force, time, and ultrasonics are critical parameters
- aluminum wire should not be used
- discrete FET devices with small pad sizes should be bonded with 0.0007-inch wire
- maximum stage temperature: 200♣C

GaAs MMIC devices are susceptible to damage from Electrostatic Discharge. Proper precautions should be observed during handling, assembly and test.